

Fig. 1

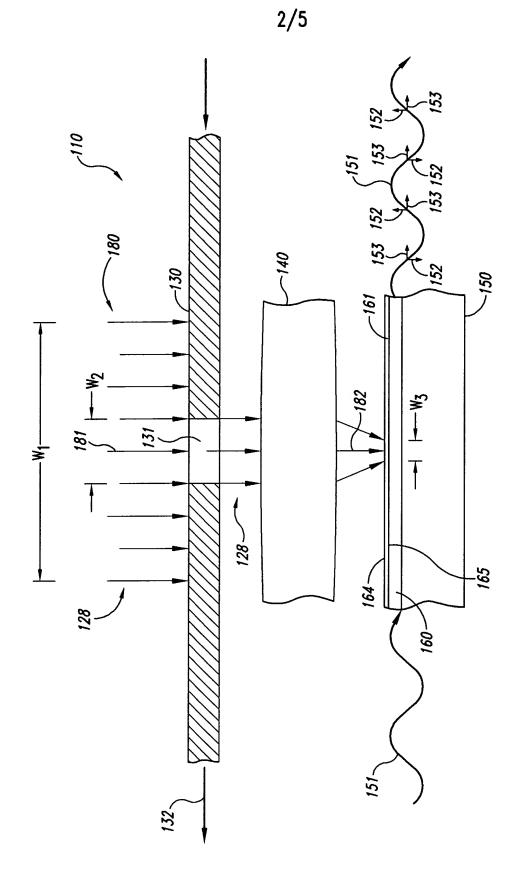
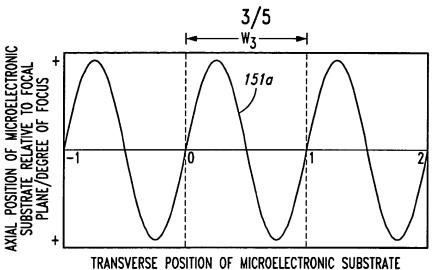
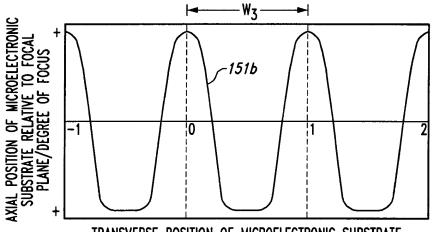


Fig. 2



TRANSVERSE POSITION OF MICROELECTRONIC SUBSTRATE (NORMALIZED TO MOTION RELATIVE TO BEAM OF ONE BEAM WIDTH (W<sub>3</sub>) AT THE MICROELECTRONIC SUBSTRATE)



TRANSVERSE POSITION OF MICROELECTRONIC SUBSTRATE (NORMALIZED TO MOTION RELATIVE TO BEAM OF ONE BEAM WIDTH (W3) AT THE MICROELECTRONIC SUBSTRATE)

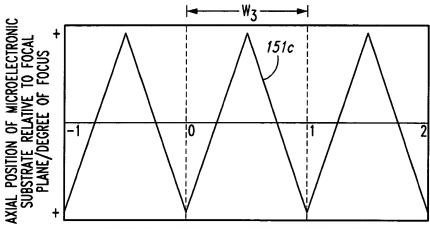


Fig. 3C

Fig. 3A

Fig. 3B

TRANSVERSE POSITION OF MICROELECTRONIC SUBSTRATE (NORMALIZED TO MOTION RELATIVE TO BEAM OF ONE BEAM WIDTH (W3) AT THE MICROELECTRONIC SUBSTRATE)

